



Docket No.: 62940(70904)
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Takaya Nakabayashi et al.

Application No.: 10/525,901

Confirmation No.: 9196

Filed: February 24, 2005

Art Unit: 4172

For: PATTERN FORMATION SUBSTRATE AND
METHOD FOR PATTERN FORMATION

Examiner: A. M. Weddle

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INTRODUCTORY COMMENTS

In response to the Office Action dated April 22, 2008, please amend the above-identified U.S. patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Remarks/Arguments begin on page 8 of this paper.